

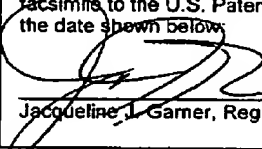
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 09/921,364 Confirmation No. 6223
Applicant: Lucius M. Sherwin TC/A.U.: 2877
Filed: 8/2/2001 Examiner: Khaled Brown
Docket No.: TI-30661 Customer No.: 23494
Title: A PARTICLE DETECTION AND REMOVAL APPRATUS FOR USE ON
WAFER FABRICATION EQUIPMENT TO LOWER TOOL RELATED DEFECTS
FROM PARTICLE CONTAMINATION

REQUEST FOR EXTENSION OF TIME

Commissioner of Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION	
I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below.	
 Jacqueline J. Garner, Reg. No. 36,144	January 7, 2004 Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

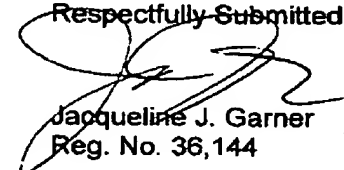
The fee for this extension is indicated below:

- ☐ One Month (\$110)
☐ Two Months (\$420)
☒ Three Months (\$950)
☐ Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary extension of time is hereby requested. Charge any and all fees to deposit account no. 20-0668. An original and two copies of this sheet are enclosed.

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Respectfully Submitted,


Jacqueline J. Garner
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